



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450  
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 4337

SERIAL NUMBER 10/603,924	FILING DATE 06/24/2003  RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. JC-7109-CIP	
APPLICANTS  Shao-Chung Hu, Taipei, TAIWAN;  Teng-Chun Tsai, Hsinchu, TAIWAN; Chia-Lin Hsu, Taipei, TAIWAN; Yung-Tsung Wei, Tainan Hsien, TAIWAN;  ** CONTINUING DATA ***** This application is a CIP of 09/854,006 05/10/2001 PAT 6,696,361  ** FOREIGN APPLICATIONS ***** TAIWAN 90109738 04/24/2001  IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/11/2003					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged		STATE OR COUNTRY TAIWAN	SHEETS DRAWING 4	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 2
ADDRESS WU & CHEUNG, LLP SUITE 710 7700 IRVINE CENTER DRIVE IRVINE, CA 92618-3043					
TITLE Post-CMP removal of surface contaminants from silicon wafer					
FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )		